NOTES:

- SUBSTRATE: Fused Silica
- 2. SURFACE \$1 TO BE PARALLEL TO SURFACE \$2 TO WITHIN <3 ARCMINS
- 3. COATING (APPLY ACROSS COATING APERTURE)

S1: R(ABS) >99.8% @ 1030nm DAMAGE THRESHOLD, PULSED: 20 J/cm² @ 1030nm, 20ns, 20Hz CW: 1 MW/cm² @ 1030nm

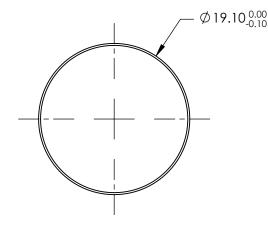
S2: NONE

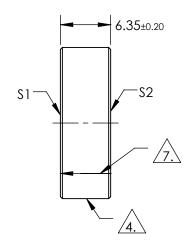


4. FINE GROUND SURFACE

- 5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
- 6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY **ACROSS CLEAR APERTURE**

ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS **TOWARDS SURFACE S1**





PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

	\$1	\$2	
SHAPE	PLANO	PLANO	
SURFACE QUALITY	10-5	COMMERCIAL POLISH	
SURFACE FLATNESS	0.10 WAVE	N/A	
MIN CLEAR APERTURE	Ø17.19	N/A	TH PR
MIN COATNG APERTURE	Ø17.19	N/A	L
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	A
			_

	Edmund Optics®			
THIRD ANGLE PROJECTION		TITLE	19.1mm Dia. 1030nm 45°, Yb:YAG Laser Line Mirror	
ALL DIMS IN	mm	DWG NO	11293	SHEET 1 OF 1